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#2 Peramot. A 4-20-10 Ratura

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
) Docket Number: 92-0501.02
Pierre C. Fazan)
Viju K. Mathews) Paper No: 1
)
Parent Serial No: 08/390,336)
)
Parent Filed: 02/17/95)
)
For: A METHOD FOR FORMING A)
STORAGE CELL CAPACITOR)
COMPATIBLE WITH HIGH)
DIELECTRIC CONSTANT)
MATERIALS	

December 14, 1995

Commissioner of Patents & Trademarks
Washington, D.C. 20231

PRELIMINARY AMENDMENT

In the specification:

Kindly delete the abstract page and insert the following page:

Micron Technology, Inc.

1

92-0501.02